

<b>Notice of References Cited</b>	Application/Control No. 10/807,636	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Nam Huynh	Art Unit 2617	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-5,943,621	08-1999	Ho et al.	455/456.3
*	C	US-2002/0187793	12-2002	Papadimitriou et al.	455/458
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	K	US-			
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	M	US-			

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**NON-PATENT DOCUMENTS**

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